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JC20 Rec'd PCT/PTO 11 MAY 2005

Docket No. 09792909-6248

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S):	Shinji Omori, et al.	ATTY. DOCKET NO.: 09792909-6248
SERIAL NO.:	Unknown	GROUP ART UNIT: Unknown
DATE FILED:	May 11, 2005	EXAMINER: Unknown
INVENTION:	"EXPOSURE APPARATUS, EXPOSURE METHOD AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD"	

Mail Stop: PCT
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. SUBMITTED US PATENT REFERENCES

	<u>Number</u>	<u>Inventor(s)</u>	<u>Date of Publication</u>
AA	5,831,272	Utsumi	November 3, 1998

II. SUBMITTED FOREIGN PATENT REFERENCES

	<u>Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	WO 03/083913	World	October 9, 2003
AI	JP2003-297716 (Japanese counterpart to WO 03/083913)	Japan	October 17, 2003
AJ	JP2002-270496	Japan	September 20, 2002
AK	JP06-018220	Japan	January 25, 1994
AL	JP08-203817	Japan	August 9, 1996
AM	JP11-135423 (Japanese counterpart to US 5,831,272)	Japan	May 21, 1999
AN	JP2003-318084	Japan	November 7, 2003

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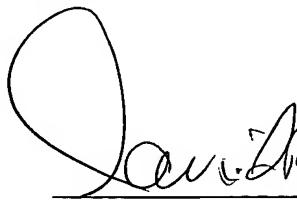
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III. OTHER ITEMS OF INFORMATION

IV. EXPLANATION OF RELEVANCE

The above-identified references were cited in the International Search Report of March 2, 2004, in counterpart PCT/JP03/14460. Copies of the International Search Report and all references are submitted herewith.

Submitted by,



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37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)		Docket No. 09792909-6248	Serial No. 10/534917
		Applicants: Shinji Omori, et al.	
		Filing Date May 11, 2005	Group Art Unit

U.S. PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
AA	5,831,272	11-3-98	Utsumi			
AB						
AC						
AD						
AE						
AF						
AG						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AH	WO 03/083913	10-9-03	World				
AI	JP2003-297716	10-17-03	Japan			Abstract	
AJ	JP2002-270496	9-20-02	Japan			Abstract	
AK	JP06-18220	1-25-94	Japan			Abstract	
AL	JP08-203817	8-9-96	Japan			Abstract	
AM	JP11-135423	5-21-99	Japan				
AN	JP2003-318084	11-7-03	Japan			Abstract	
AO							
AP							
AQ							
AR							
AS							
AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AU	
AV	
AW	
AX	
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AZ	

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.